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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE OF PAPERS ORIGINALLY FILED

Applicant(s):

Serial No.:

10/001,412

Filed:

October 25, 2001

For:

Microelectromechanical System With Improved Beam Suspension

Docket No.:

110003.97478

PRELIMINARY AMENDMENT

Commissioner for Patents Washington, D. C. 20231

Dear Sir:

Prior to the first Office Action in the above referenced case, please amend the application as follows.

IN THE TITLE

Please change the title to read as follow:

MICROELECTROMECHANICAL SYSTEM (MEMS) WITH IMPROVED BEAM

SUSPENSION.

Respectfully submitted,

PATRICK C. HERBERT et al.

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